



*H.W.*  
*15/Andtc*  
*3/10/04*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 4320**  
Norio KIMURA et al. : Docket No. 2001\_0122A  
Serial No. 09/777,707 : Group Art Unit 3723  
Filed February 7, 2001 : Examiner Maurina T. Rachuba

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POLISHING APPARATUS

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**RESPONSE**

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEE FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975.

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated November 4, 2003, having a three (3) month shortened-statutory period for response set to expire February 4, 2004, a petition for a (1) month extension of time up to and including March 4, 2004, being filed concurrently herewith, please amend the above-identified application as follows: